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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Mitsuru Ozono *et al.*
Appln. No. : 10/620,184
Filed: : July 15, 2003
Title : METHOD AND APPARATUS FOR PICKING UP SEMICONDUCTOR
CHIP AND SUCTION AND EXFOLIATION TOOL USED THEREFOR

Conf. No. : 8698
TC/A.U. : 1734
Examiner : Mark A. Osele

Customer No. : 000,116
Docket No. : 35857

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT


Sir:

In accordance with 37 CFR § 1.98, Applicant is aware of the publications listed in the International Search Report and is submitting herewith Form PTO/SB/08A listing references for consideration by the Examiner. A copy of the International Search Report and each listed publication is enclosed.

If there are any fees associated with this communication, please charge said fees to Deposit Account No. 16-0820, Order No. 35857.

Respectfully submitted,

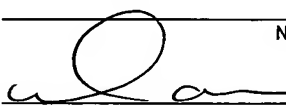
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Date: July 26, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.


Name of Attorney for Applicant(s)

Signature of Attorney

July 26, 2006
Date

